

Lab demo registration:

Tuesday (18<sup>th</sup> of July):

Session One: **Photolithography**

Roya Tavallaie
William Hales
Charles Hall
Wenxian Tang
James Slack-Smith

Session Two: **Thin film deposition**

Moonyong Kim
Divya Sehwat
Daniel Chen
Yifeng Fu
Damian Sofrevski

Session Three: **Dry etching**

Laurine Weinmann
Kathleen Djohari
Hao Li
Sanjun Fan
Nivaaz Sehmbhi

Session Four: **Chip packaging and bonding**

Binghang Wang
William Gilbert
Junnan Liu
Matt McEwen
Mohamad Azam AZMI

Lab demo registration:

Wednesday (19<sup>th</sup> of July):

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